

Supplementary Information for

## Multi-Bandgap Monolithic Metal Nanowire Percolation Network Sensor Integration by Reversible Selective Laser Induced Redox

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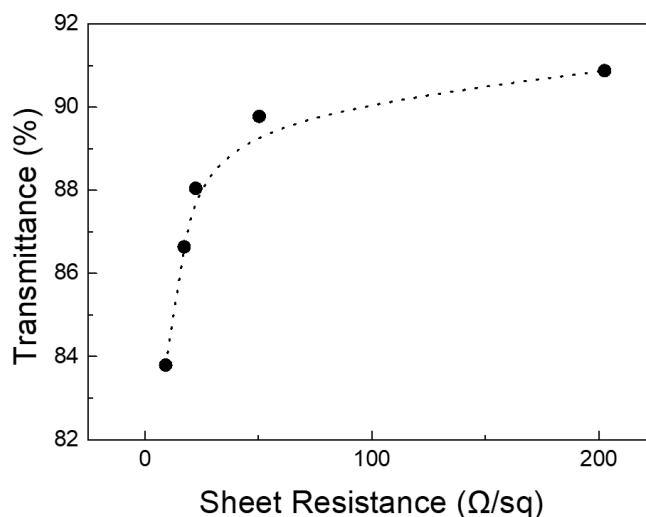
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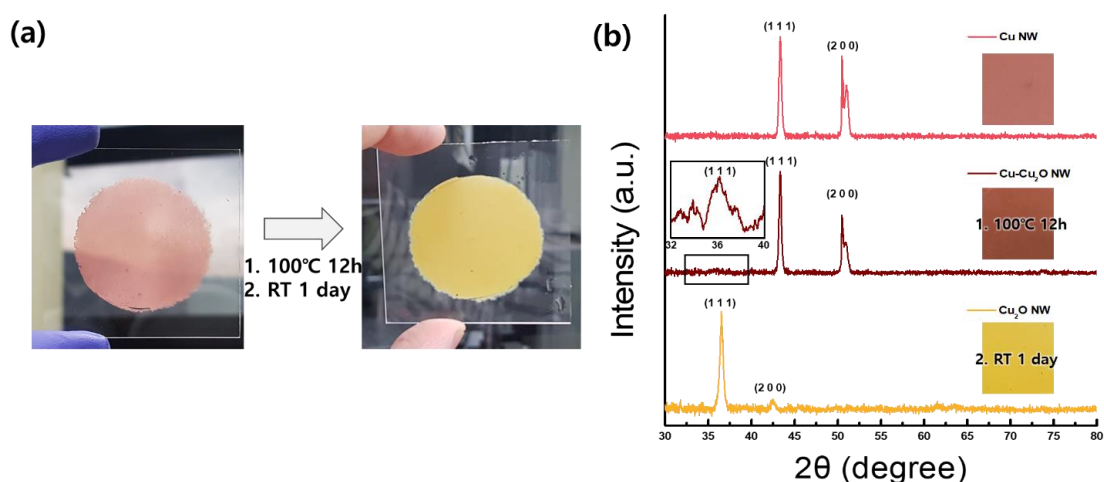
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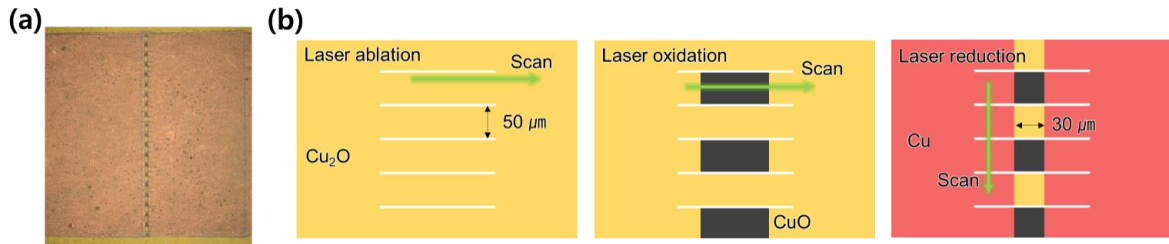
### Supplementary Figures and Tables



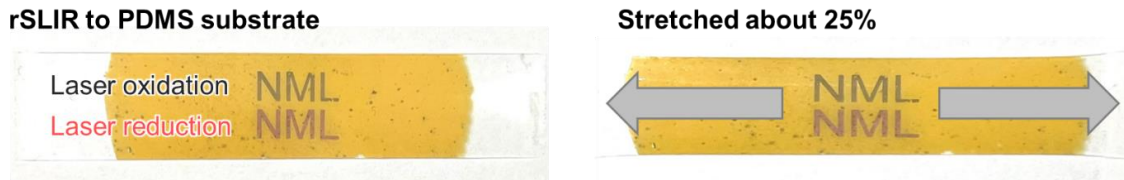
**Fig. S1** Transmittance according to the sheet resistance of the CuNW



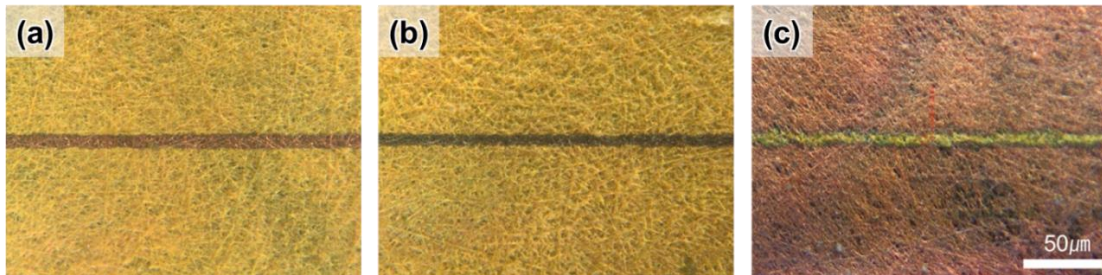
**Fig. S2** Wet oxidation to CuNW to Cu<sub>2</sub>ONW (a) the optical image of the red CuNW and the yellow Cu<sub>2</sub>ONW, (b) XRD spectra during wet oxidation



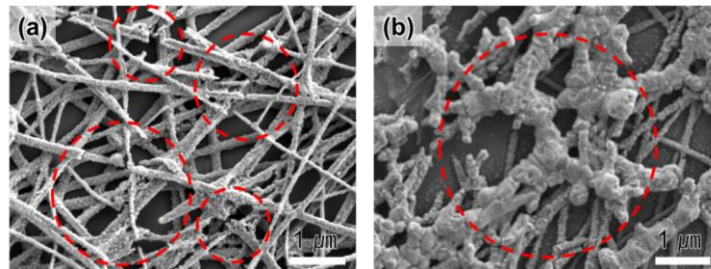
**Fig. S3** (a) The optical image of Cu-Cu<sub>2</sub>O&CuO-Cu photodetector. (b) Schematic depicting fabrication step: laser ablation → laser oxidation → laser reduction



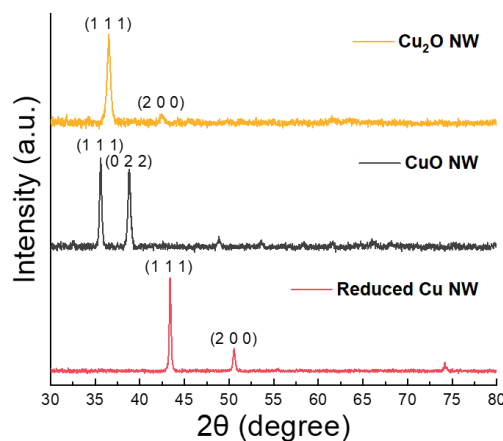
**Fig. S4** rSLIR to stretchable PDMS substrate. We first fabricate Cu<sub>2</sub>ONWs through wet oxidation. After that, CuONW and CuNW were patterned through laser oxidation and laser reduction under the conditions of 70 mW of laser power and 10 mm/s of scanning speed



**Fig. S5** Resolution of Cu-based material pattern. (a) CuNW, (b) CuONW, and (c) Cu<sub>2</sub>ONW



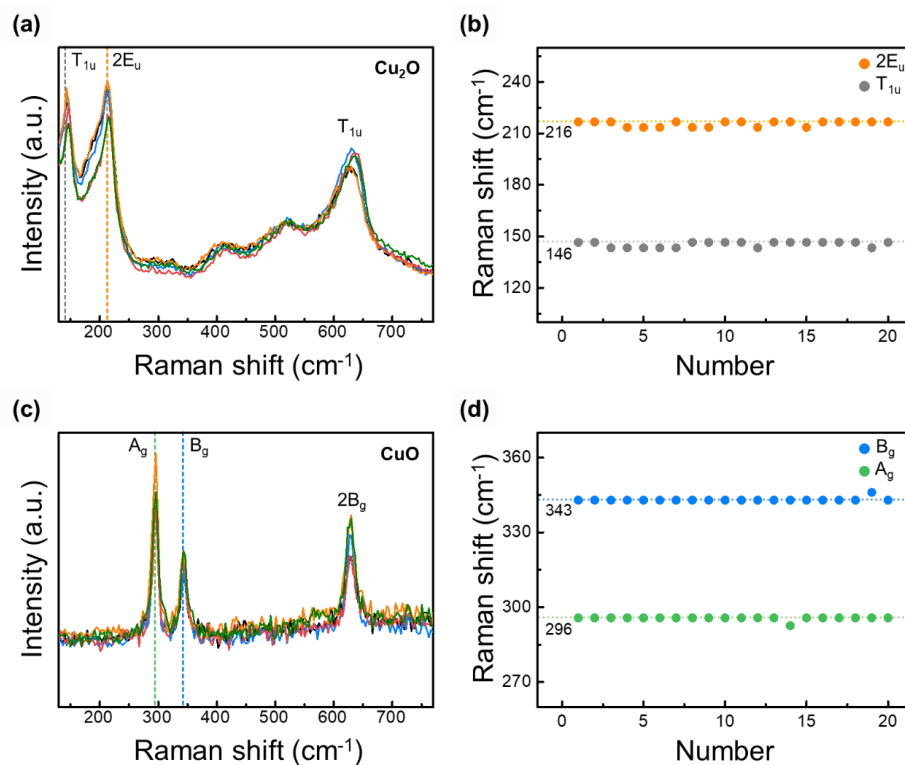
**Fig. S6** High power density laser illumination. (a) laser reduction, (b) laser oxidation



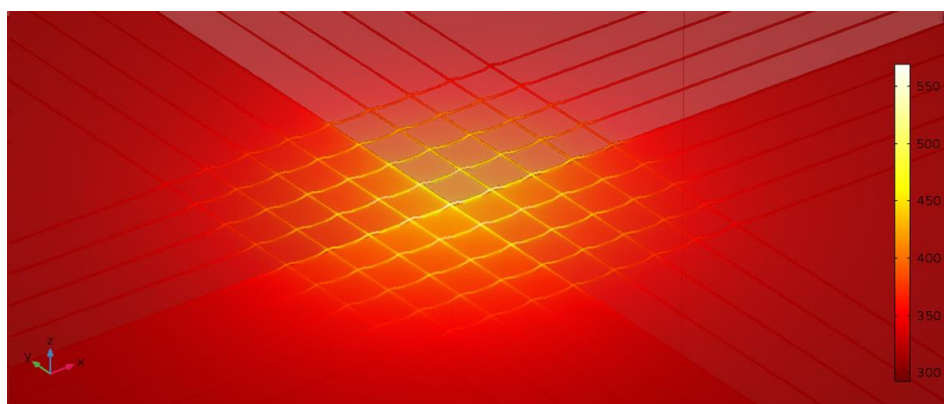
**Fig. S7** XRD spectra of Cu<sub>2</sub>ONW, CuONW, and reduced CuNW prepared on glass substrates S2 /S5

**Table S1** FWHM for the (111) peak for XRD data for Cu<sub>2</sub>ONW and CuONW

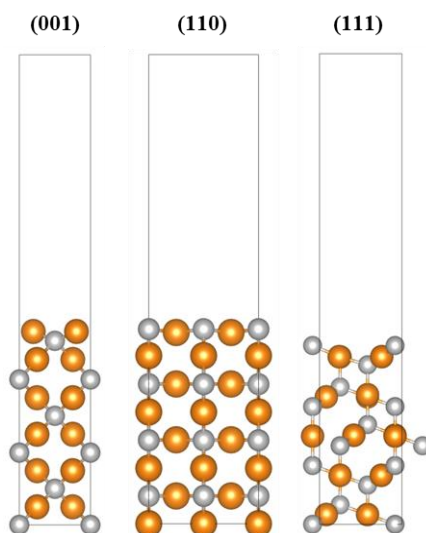
| NW                | XRD FWHM for (111) |
|-------------------|--------------------|
| Cu <sub>2</sub> O | 0.408              |
| CuO               | 0.266              |



**Fig. S8** Repeatability of Cu<sub>2</sub>ONW and CuO NW. (a) The overlapped Raman spectrum measured at 5 points without intensity calibration. All results show similar inclination, peaks, and intensities. (b) The main peaks ( $T_{1u}$  : 146  $\text{cm}^{-1}$ ,  $2E_u$  : 216  $\text{cm}^{-1}$ ) of the Raman spectrum at random 20 points of Cu<sub>2</sub>ONW. (c, d) The same analysis results for CuONW. ( $A_g$  : 296  $\text{cm}^{-1}$ ,  $B_g$  : 343  $\text{cm}^{-1}$ )



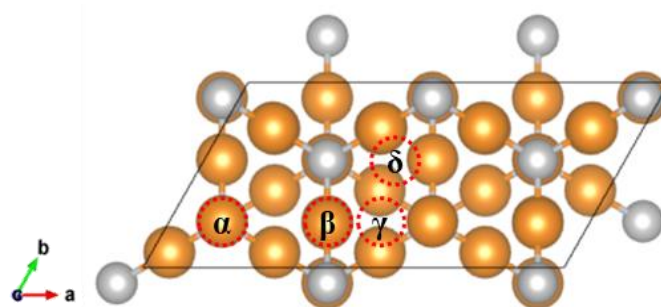
**Fig. S9** Comsol image of Finite element method simulation at laser illumination to nanowires network (beam spot size of 20  $\mu\text{m}$  and a power of 40 mW)



**Fig. S9** The slab models of the (001), (110), and (111) planes of  $\text{Cu}_2\text{O}$  for DFT calculation of surface energy

**Table S2** The surface energy for the (001), (110), and (111) planes of  $\text{Cu}_2\text{O}$

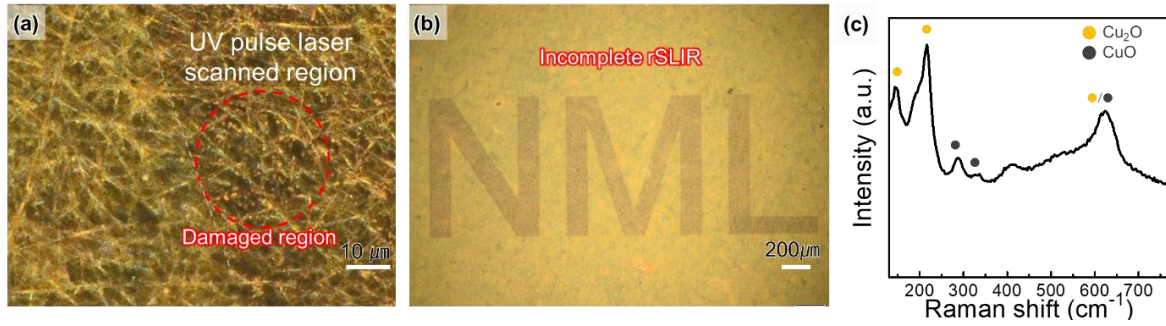
| Surface | Surface energy ( $\text{J}/\text{m}^2$ ) |
|---------|--|
| (001)   | 1.318                                    |
| (110)   | 1.159                                    |
| (111)   | 0.772                                    |



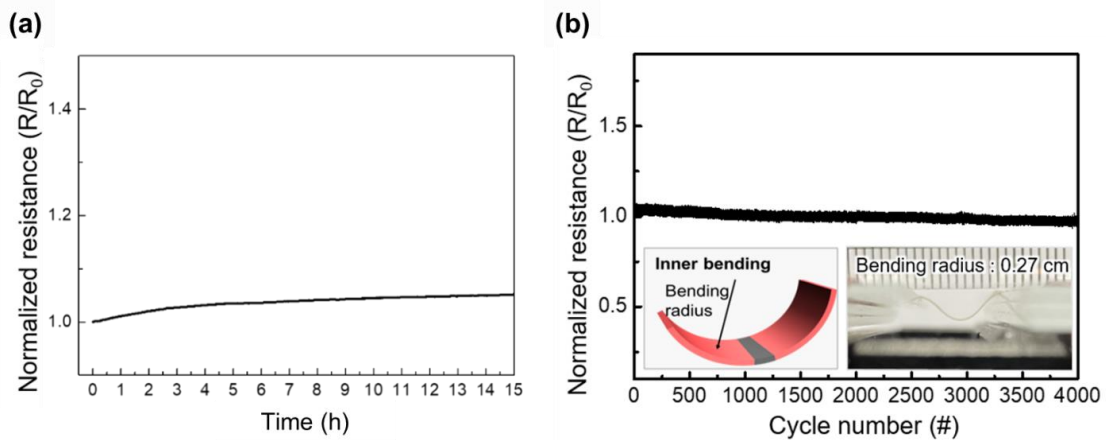
**Fig. S10** The possible  $\text{O}_2$  molecule adsorption sites on  $\text{Cu}_2\text{O}(111)$  surface

**Table S3** The adsorption energy for the possible  $\text{O}_2$  molecule adsorption sites on  $\text{Cu}_2\text{O}(111)$  surface

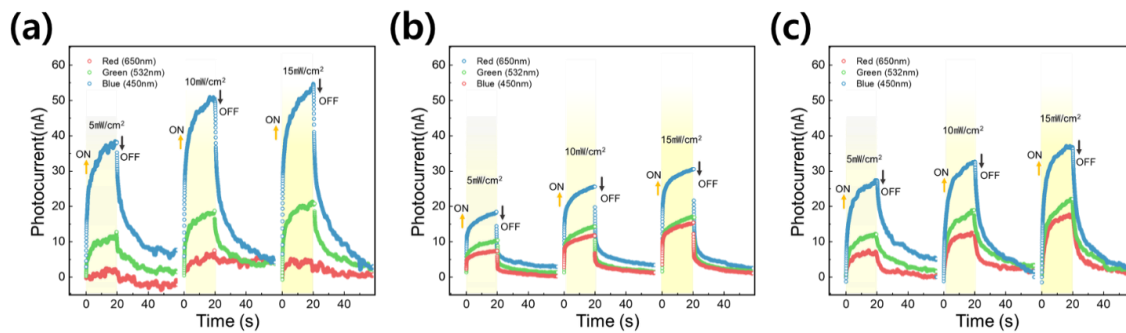
| Adsorption site | Adsorption energy (eV) |
|-----------------|------------------------|
| $\alpha$        | -1.068                 |
| $\beta$         | -0.438                 |
| $\gamma$        | -1.156                 |
| $\delta$        | -1.067                 |



**Fig. S11** Pulsed laser rSLIR. **(a)** An optical image of the nanowire network after ten cycles of hatch scanning at 1.68 mW. Unlike continuous laser oxidation, it does not change to black color, and even nanowires are ablated and damaged. **(b)** Pulsed laser oxidation with slightly lower power. complete oxidation does not occur even with 20 laser scanning cycles. **(c)** Raman spectrum of incomplete laser oxidation



**Fig. S12** **(a)** Resistant change of CuNW network during 85/85test. **(b)** Cyclic bending test at bending radius of 0.27cm



**Fig. S13** The behaviors of three types of photodetectors varying luminous light wavelength and intensity **(a)** Cu-Cu<sub>2</sub>O-Cu photodetector, **(b)** Cu-CuO-Cu photodetector, and **(c)** Cu-Cu<sub>2</sub>O&CuO-Cu photodetector